

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|---------------------|
| S79 | 2 | ("4704300").PN. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/17 14:31 |
| S83 | 2 | ((fluorine (F near (atoms ions))) near concentration) same S82 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 14:51 |
| S82 | 4370 | S80 S81 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 14:51 |
| S81 | 388 | a-SiN "a-Si.sub"\$N. sub"\$4 "a - Si.sub"\$N. sub"\$4 "a - Si.sub"\$N. sub"\$4 "a - Si.sub"\$N. sub"\$4 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 14:51 |
| S80 | 4093 | amorphous near2 (SiN (silicon near nitride) "Si.sub"\$N.sub"\$4) | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 14:51 |
| S85 | 8 | ((fluorine (F near (atoms ions))) same concentration) same S82 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:14 |
| S84 | 8 | ((fluorine (F near (atoms ions))) with concentration) same S82 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:14 |
| S86 | 2 | ("20050223986").PN. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/17 15:16 |
| S89 | 55 | S87 S88 | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:19 |

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|-----|------|--|---|----|-----|---------------------|
| S88 | 19 | ("20020117691" "20040127033" "20050223986" "4838652" "5712208" "5812284" "5834345" "5837614" "7095460" "7220991").PN. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:19 |
| S87 | 36 | ("20030066607" "20030097987" "20030124848" "20040039989" "20050233092" "20050251990" "20050255257" "4854263" "5439524" "6024799" "6040022" "6050506" "6106663" "6132512" "6454860" "6565661" "6823589" "6942753" "7052622" "7462564").PN. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:19 |
| S90 | 281 | ((fluorine (F near (atoms ions))) same concentration) same (SiN (silicon near nitride) "Si. sub"\$N.sub"\$4) | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:24 |
| S91 | 26 | ((fluorine (F near (atoms ions))) same concentration) same (SiN (silicon near nitride) "Si. sub"\$N.sub"\$4) same (gate near (dielectric insulat\$3)) | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/17 15:25 |
| S94 | 27 | ((((fluorine (F near (atoms ions))) and concentration) and (SiN (silicon near nitride) "Si.sub"\$N. sub"\$4) and (gate near (dielectric insulat\$3))))).clm. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/18 13:21 |
| S95 | 1116 | (257/410).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/18 13:51 |
| S96 | 3 | ("2005/0223986").URPN. | USPAT | OR | ON | 2009/03/18 14:27 |
| S97 | 166 | S95 and (halogen fluorine) | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2009/03/18 15:07 |

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| S98 | 32 | ("4772927" "4810673" "4894352" "4943837" "5013691" "5037766" "5275977" "5313075" "5313076" "5403772"). PN. OR ("5866932"). URPN. | US-PGPUB; USPAT; USOCR | OR | ON | 2009/03/18 15:13 |
| L2 | 920 | (257/57).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/19 05:36 |
| L3 | 1105 | (257/E21.625).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/19 05:41 |
| L4 | 1176 | (257/291).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/19 05:48 |
| L6 | 951 | (438/482).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/19 06:44 |
| L7 | 2584 | (438/197).CCLS. | US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/03/19 06:46 |

3/19/2009 7:00:04 AM

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